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PATENT
450106-05232

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Kenji HYODO et al.
International Application No.: PCT/JP2004/008410
International Filing Date: June 9, 2004
Serial No.: 10/559,953
For: INFORMATION PROCESS APPARATUS AND
METHOD, PROGRAM RECORD MEDIUM, AND
PROGRAM

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New York, NY 10151

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on June 29, 2007.

Paul A. Levy, Reg. No. 45,748

Name of Applicant, Assignee or Registered Representative

Signature

June 29, 2007

Date of Signature

INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. 1.97 (b)

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In compliance with the duty of disclosure set forth in 37 C.F.R. 1.56, applicants are filing this Information Disclosure Statement and the accompanying form PTO-1449 along with copies of the prior art therein identified. Such prior art has come to the attention of applicants by being cited in an Office Action issued in the corresponding Japanese application on

July 18, 2006. So far as applicants are aware, this Information Disclosure Statement is being filed before the mailing date of the first Office Action on the merits.

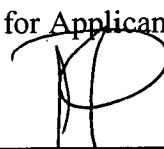
The filing of this Information Disclosure Statement is not an admission that the documents identified herein constitute prior art to the present application.

Please charge any fees incurred by the filing of this document or credit any overpayment to Deposit Account No. 50-0320.

Respectfully submitted,

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Based on Form PTO-1449 (3/90)	ATTY. DOCKET NO. 450106-05232	INTERNATIONAL SERIAL NO. PCT/JP2004/008410
	APPLICANT Kenji HYODO et al.	
	INT'L FILING DATE June 9, 2004	GROUP Unknown

LIST OF REFERENCES CITED BY APPLICANT
(Use several sheets if necessary)

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
/M.D./	AL	5 325500	12/10/93	Japan			X
/M.D./	AM	2002 25230	01/25/02	Japan			X
	AN						
	AO						
	AP						

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	AQ		
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	AS		

EXAMINER /Mishawn Dunn/	DATE CONSIDERED 03/14/2011
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* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.